

## **Supporting Information**

### **Large-area, Conductive and Flexible Reduced Graphene Oxide (RGO)**

### **Membrane Fabricated by Electrophoretic Deposition (EPD)**

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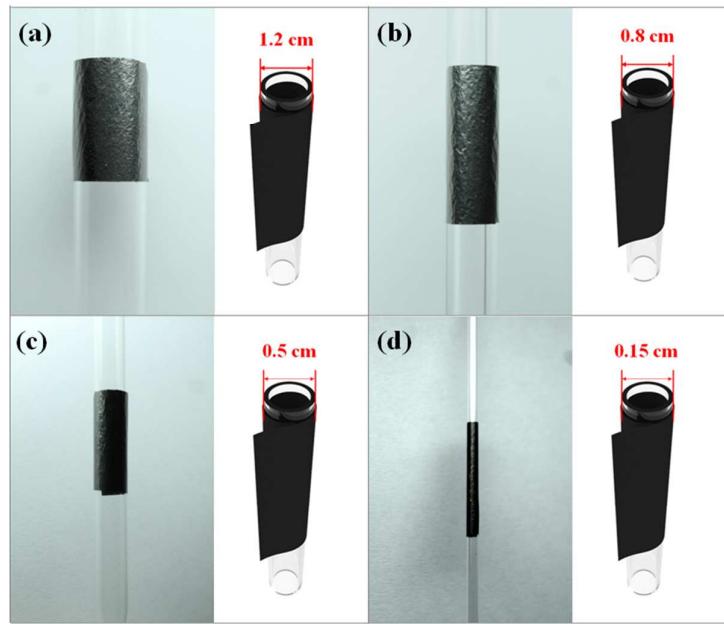
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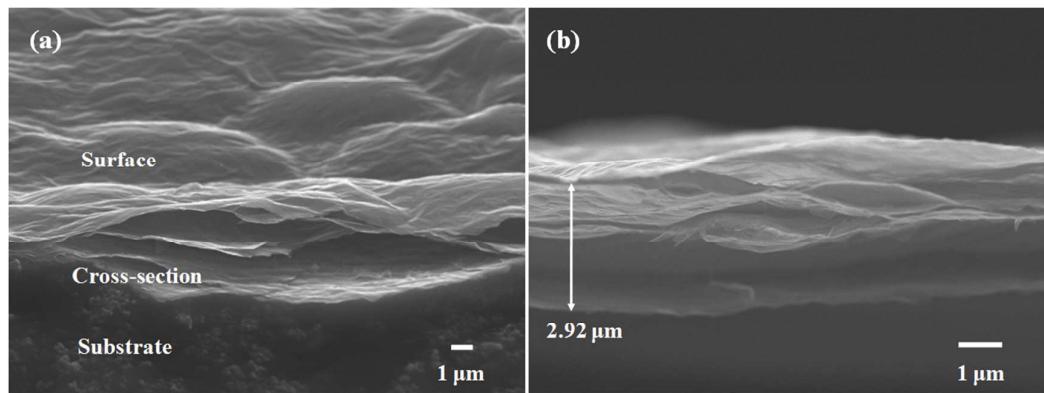
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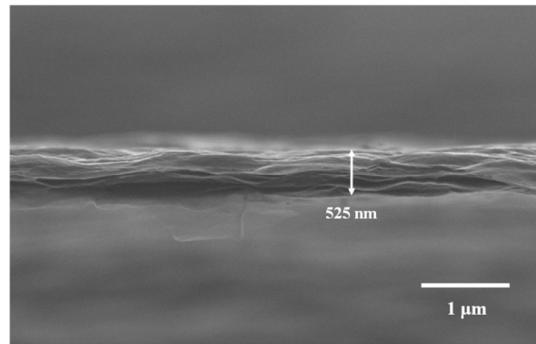


**Figure S1.** RGO membrane rolled onto glass tubes with diameter of 1.2 cm (a), 0.8 cm (b), 0.5 cm (c), and 0.15 cm (d).

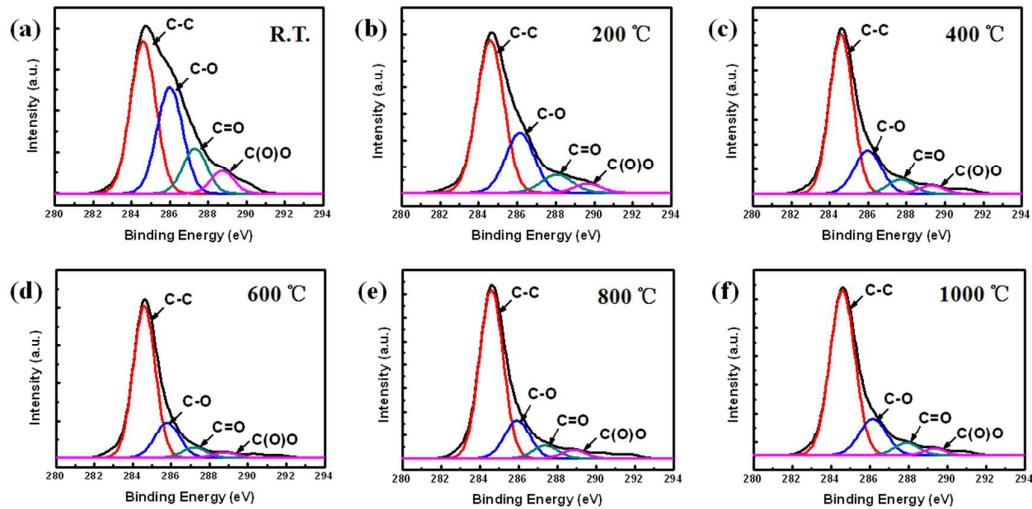


**Figure S2.** RGO membrane annealing at 600 °C heated without being packed by quartz plate.

(a) Interlayer distance of RGO membrane expands after annealing. (b) Thickness of RGO membrane increases to 2.92  $\mu\text{m}$  after annealing.



**Figure S3.** SEM image of RGO membrane detached by chemical etching method.



**Figure S4.** C1s spectra of RGO membrane with annealing temperature at (a) R.T.; (b) 200 °C; (c) 400 °C; (d) 600 °C; (e) 800 °C; and (f) 1000 °C.

Sample name	C	O
RGO-R.T	72.212	27.788
RGO-200	78.604	21.396
RGO-400	82.668	17.332
RGO-600	84.106	15.894
RGO-800	88.227	11.773
RGO-1000	94.338	5.662

**Table S1.** C and O atomic composition list of RGO membranes with different annealing temperature.